Record Nr. UNINA9910298462203321 Autore Zhang Rui-Qin Titolo Growth mechanisms and novel properties of silicon nanostructures from quantum-mechanical calculations / / Rui-Qin Zhang Heidelberg, Germany:,: Springer,, 2014 Pubbl/distr/stampa 3-642-40905-9 **ISBN** Edizione [1st ed. 2014.] Descrizione fisica 1 online resource (viii, 66 pages): illustrations (some color) Collana SpringerBriefs in Molecular Science, , 2191-5415 Disciplina 620.5 Soggetti Nanostructured materials Silicon - Industrial applications Quantum theory Lingua di pubblicazione Inglese **Formato** Materiale a stampa Livello bibliografico Monografia Note generali "ISSN: 2191-5407." Nota di bibliografia Includes bibliographical references. Introduction -- Growth mechanism of silicon nanowires -- Stability of Nota di contenuto silicon nanostructures -- Novel electronic properties of silicon nanostructures -- Summary and remarks. In this volume, Prof. Zhang reviews the systematic theoretical studies in Sommario/riassunto his group on the growth mechanisms and properties of silicon quantum dots, nanotubes and nanowires, including: mechanisms of oxideassisted growth of silicon nanowires, energetic stability of pristine silicon nanowires and nanotubes, thermal stability of hydrogen terminated silicon nanostructures, size-dependent oxidation of hydrogen terminated silicon nanostructures, excited-state relaxation of hydrogen terminated silicon nanodots, and direct-indirect energy band transitions of silicon nanowires and sheets by surface engineering and straining. He also discusses the potential applications of these findings. This book will mainly benefit those members of the scientific and research community working in nanoscience, surface science,

nanomaterials and related fields.